

# Status of Shintake-monitor Optics (focused on phase stabilization)

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On behalf of ATF2 Shintake-monitor group

# Topics

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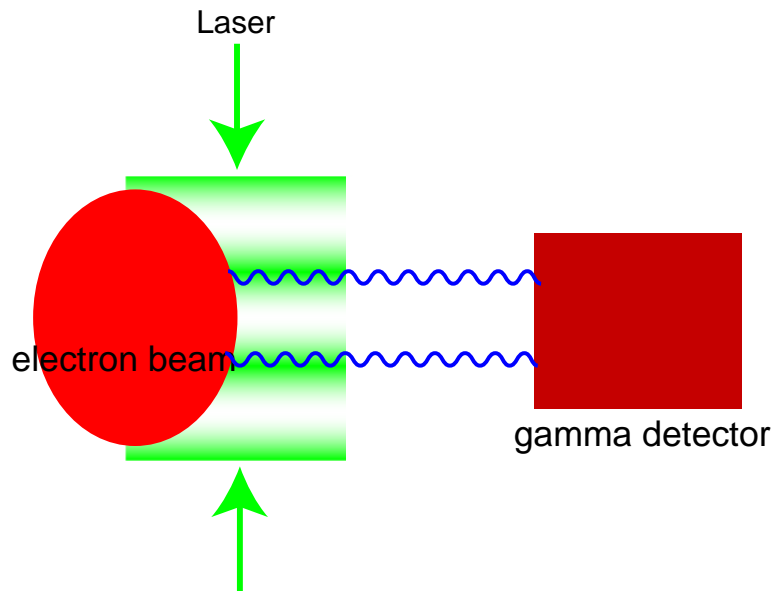
# Overview

Shintake-monitor principle

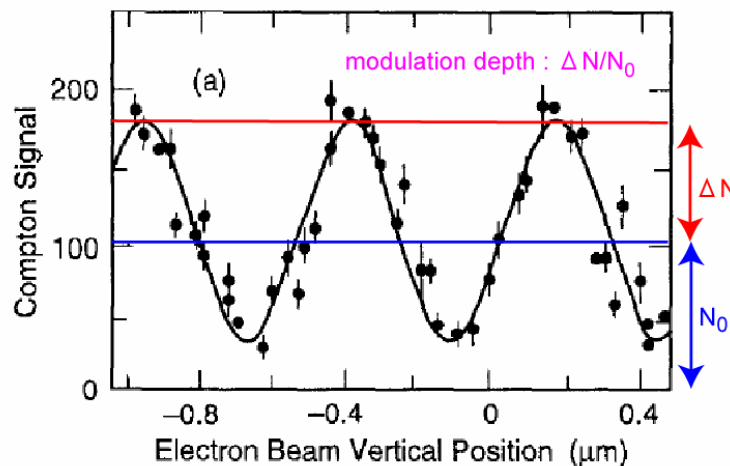
Table layout

Comparison between FFTB & ATF2

# Shintake-monitor Principle

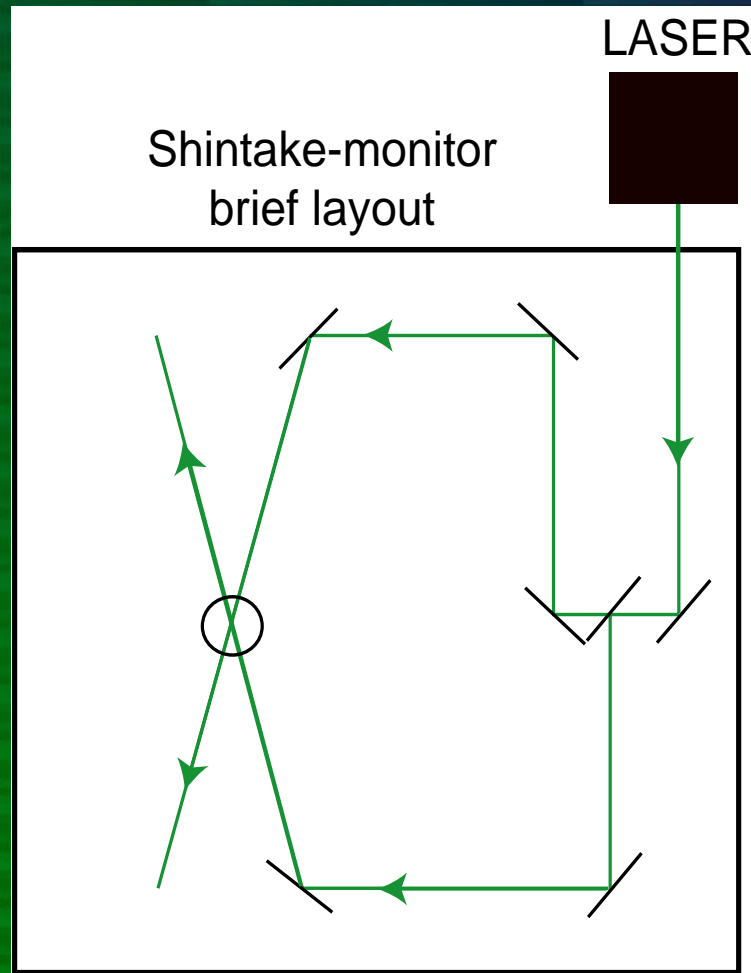


- Electron beam is scattered with laser photons at IP and emits gamma-rays.
- If electron beam is well focused, number of gamma-rays is largely modulated by the phase of the fringe.
- If not well focused, number of gamma is not so largely modulated.



- Practically, we measure the modulation of gamma-ray signal monitored downstream IP.
- The “modulation depth” can easily be converted to beam size.
- The left figure is FFTB result. It corresponds to 70nm beam size.

# Table Layout



Laser beam is split and go across  
the IP from opposite direction.  
Size is 1.5m x 1.5m.



Picture of Shintake-monitor  
Front optical table is  
for laser optics tuning.  
We are using low power cw.  
test laser now.

# Comparison between FFTB and ATF2

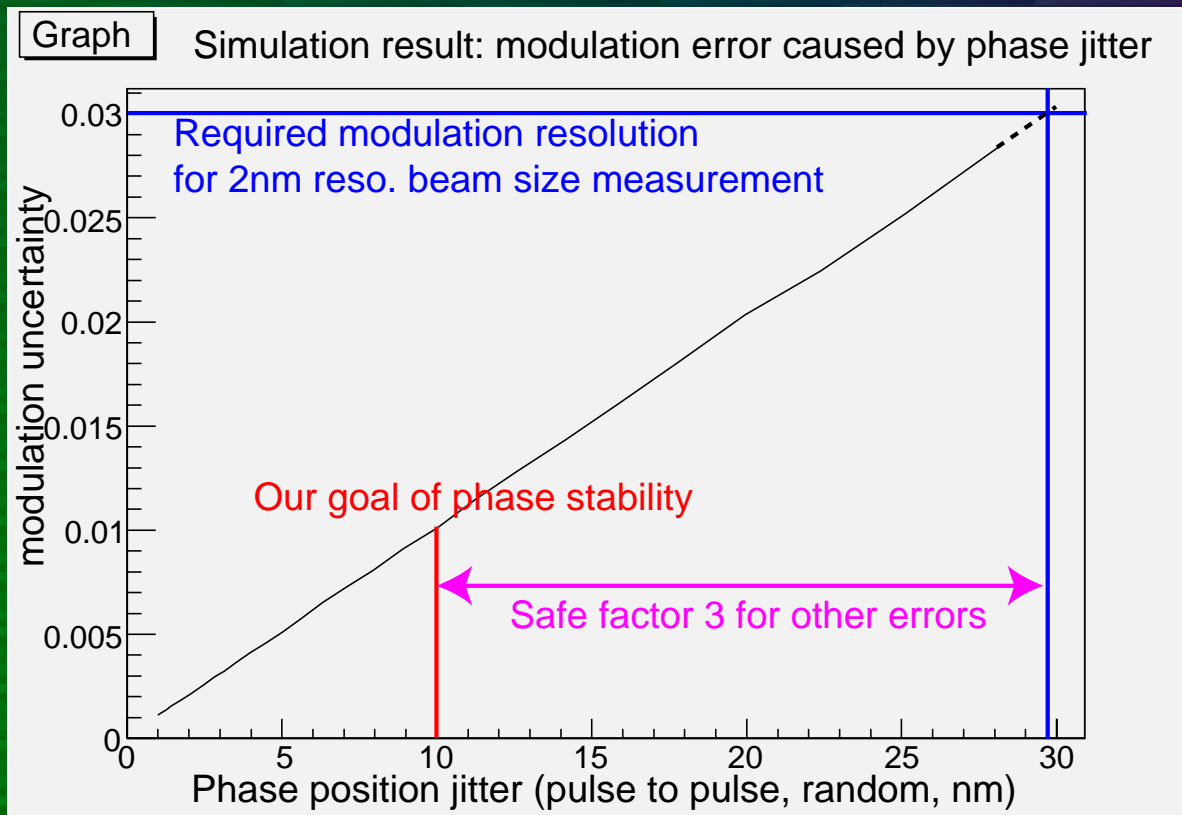
	FFTB	ATF2 (plan)
Target	Test of monitor itself Obtain beam size	Tool for tuning High resolution
Period	1992 - 1997	2008-
Beam size @ IP	70 nm (meas.)	35 nm (plan)
Rep. rate	30 Hz	1.5 – 3 Hz
Laser wavelength	1064 nm	532 nm
Beam size resolution	Not specified ("less than" 70nm)	< 2nm
Measurement time	1 hour?? (iteration because of bad resolution)	1 minute (no iteration)

# Status & Issues

Required laser fringe phase stability  
Fringe phase monitor method & location  
Phase scanning system  
Phase stabilization test  
Other status

# Required Fringe Stability

2nm beam size (required resolution) corresponds to 3% modulation (around 35nm). **We need 3% modulation resolution.**



- modulation uncertainty is proportional to phase jitter.
- **About 30nm stability corresponds to 3% (goal) modulation uncertainty.**
- But we should consider another errors. We keep safe factor 3.

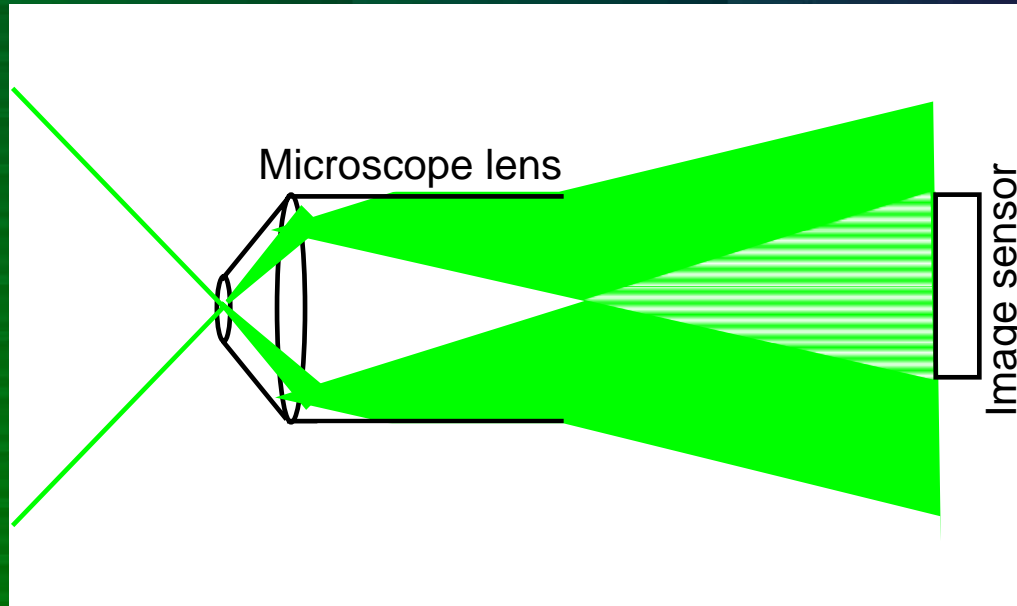
As a result,

**We should develop a 10nm level fringe phase stabilization system.**



# The Method of Phase Detection

Fringe magnification by a lens with a linear image sensor

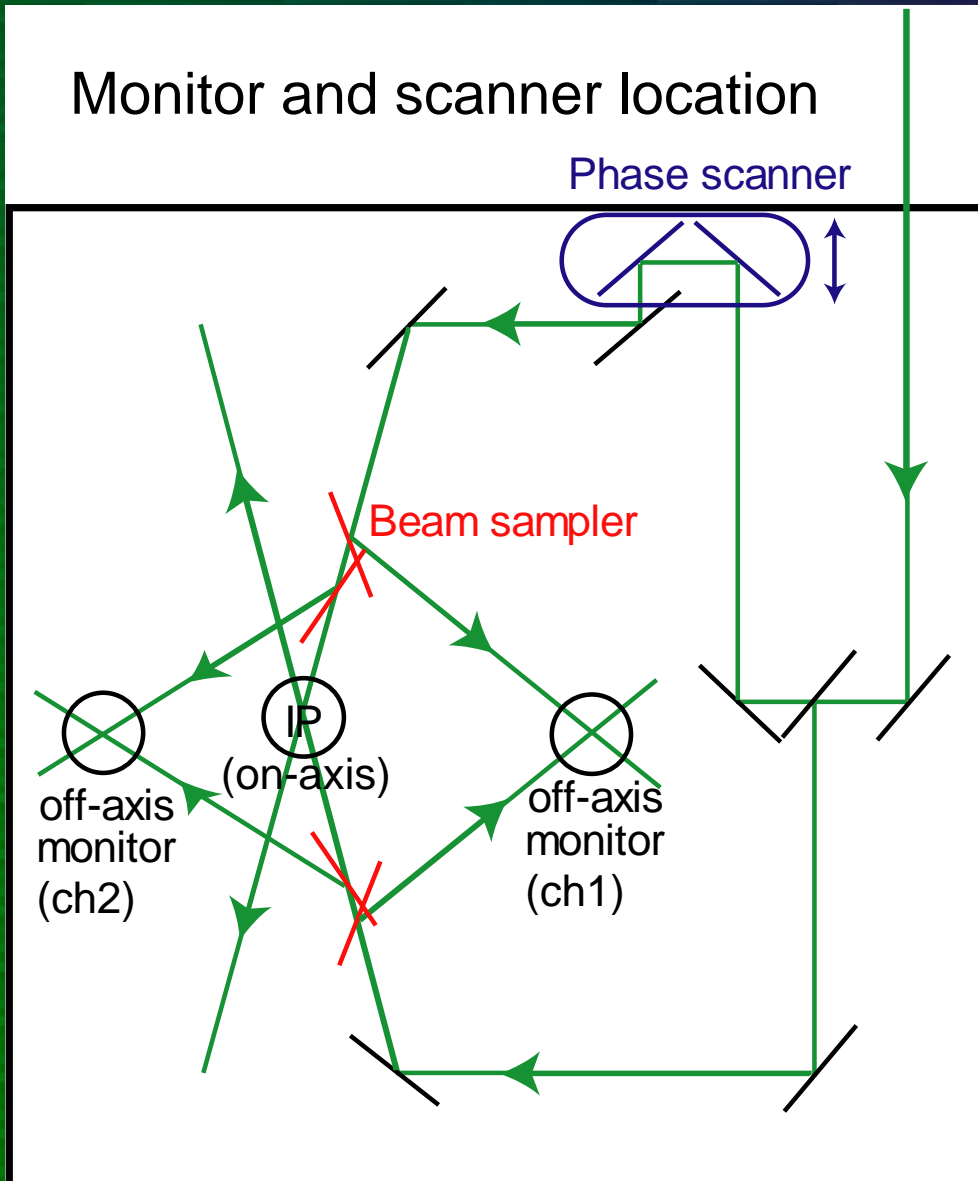


- The laser beams pass through the microscope lens to be magnified, and create fringe pattern. (lens works like a double slit)
- The phase of the fringe corresponds to relative phase of 2 laser beams.

- We obtain the phase by Fourier transform method.  
Resolution of phase calculation estimated to be  $< 0.1$  rad.  
(i.e. about 5nm)

# Location of Monitors and a Scanner

## Monitor and scanner location



- We cannot place the phase monitor on IP. We place it “**off-axis**” position.
- To cancel out difference of the phase between IP and monitor position, **we place the same monitor on the opposite position (ch2)**
- We place a phase scanner (delay line with piezo mover) on one side.  
**We need no beam steering for scanning fringe phase.**

# Setup

Linear image sensor

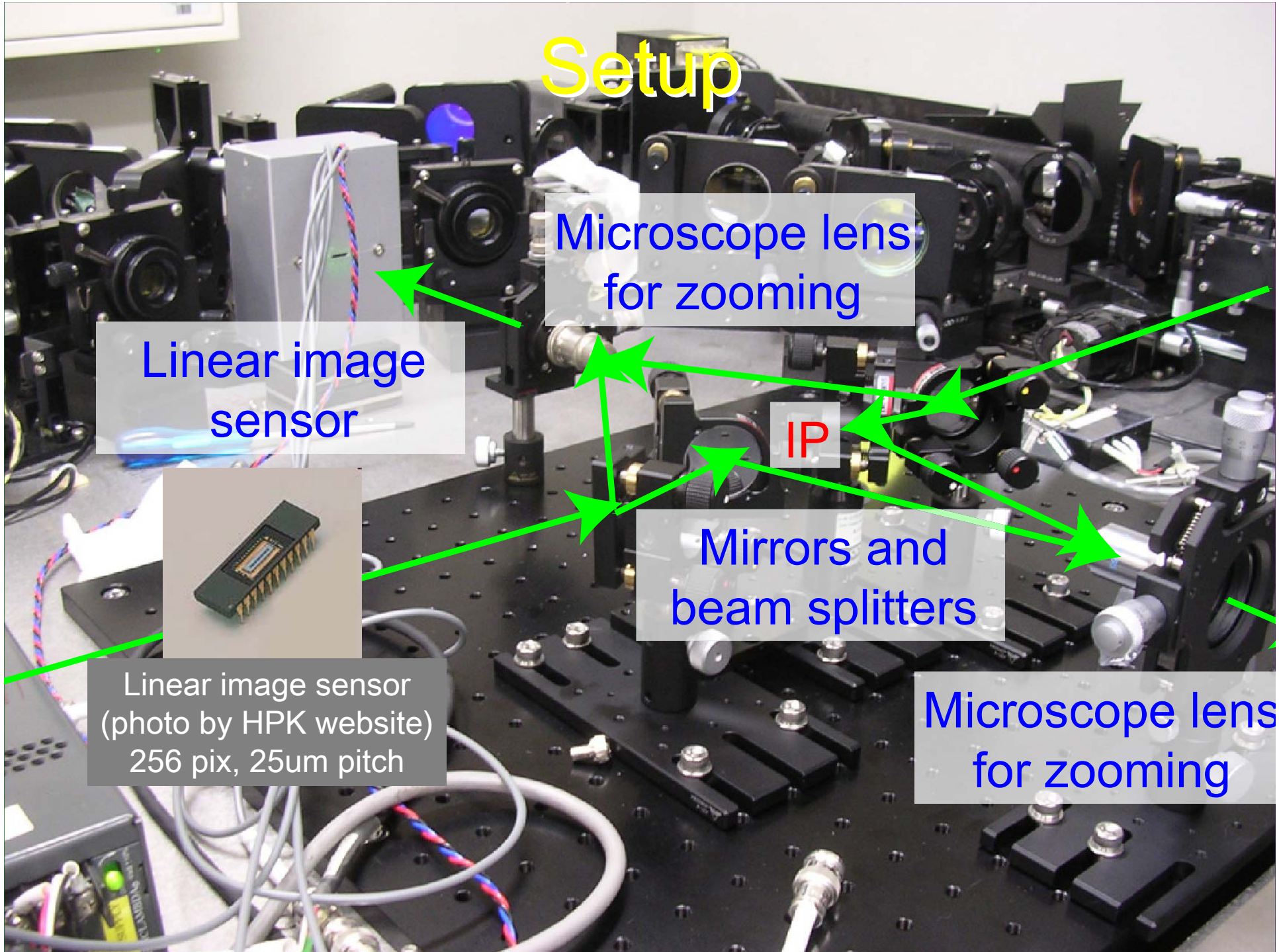
Microscope lens for zooming

IP

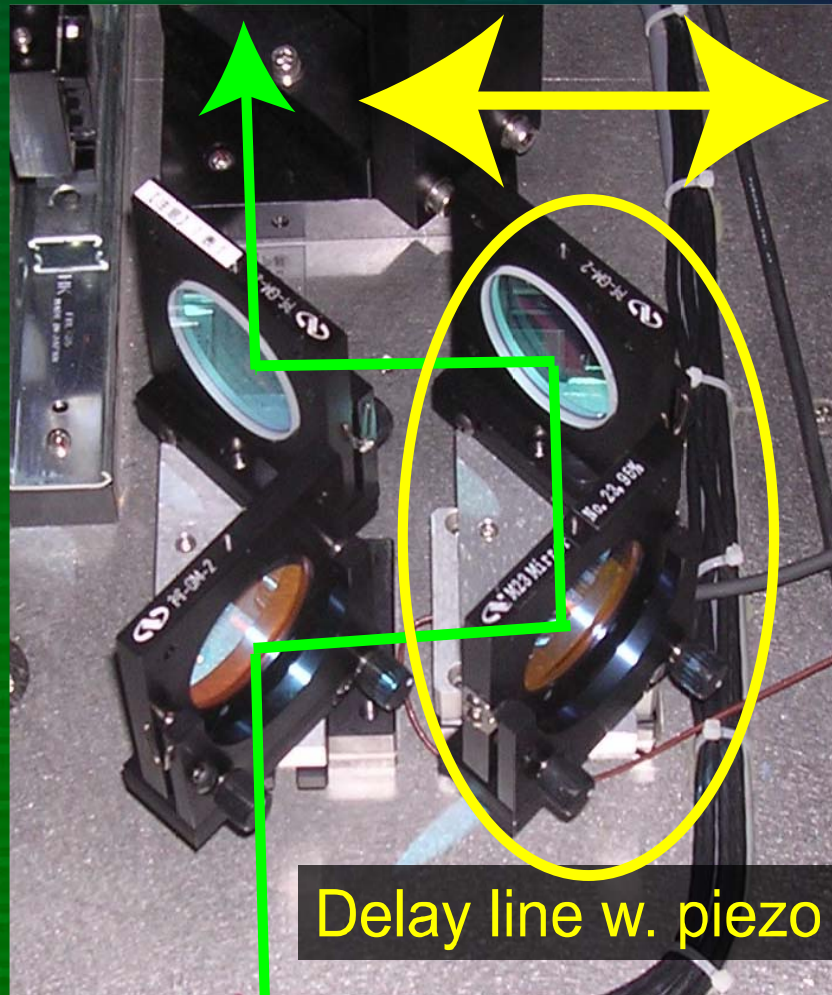
Mirrors and beam splitters

Microscope lens for zooming

Linear image sensor  
(photo by HPK website)  
256 pix, 25um pitch

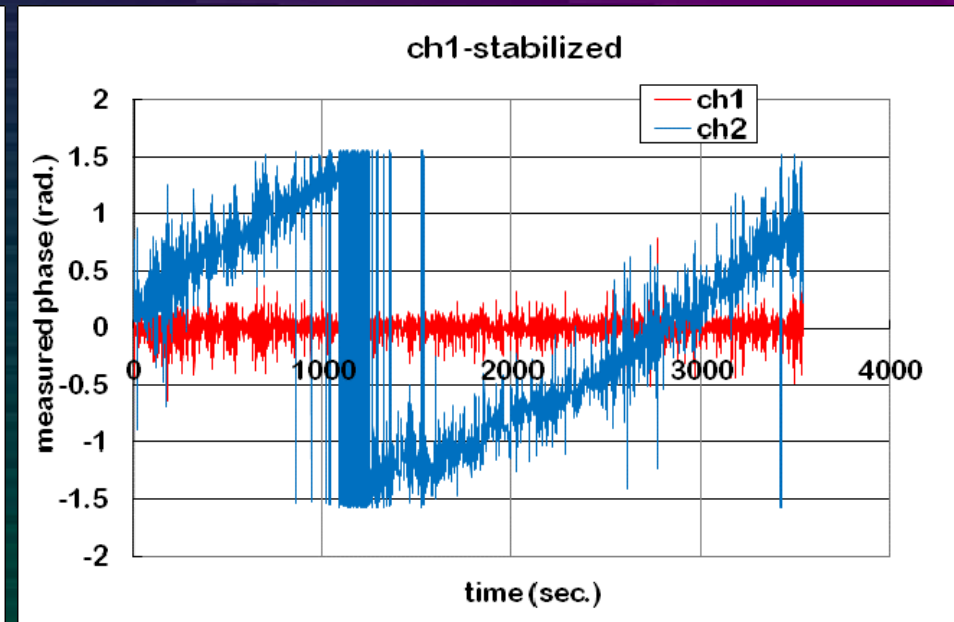
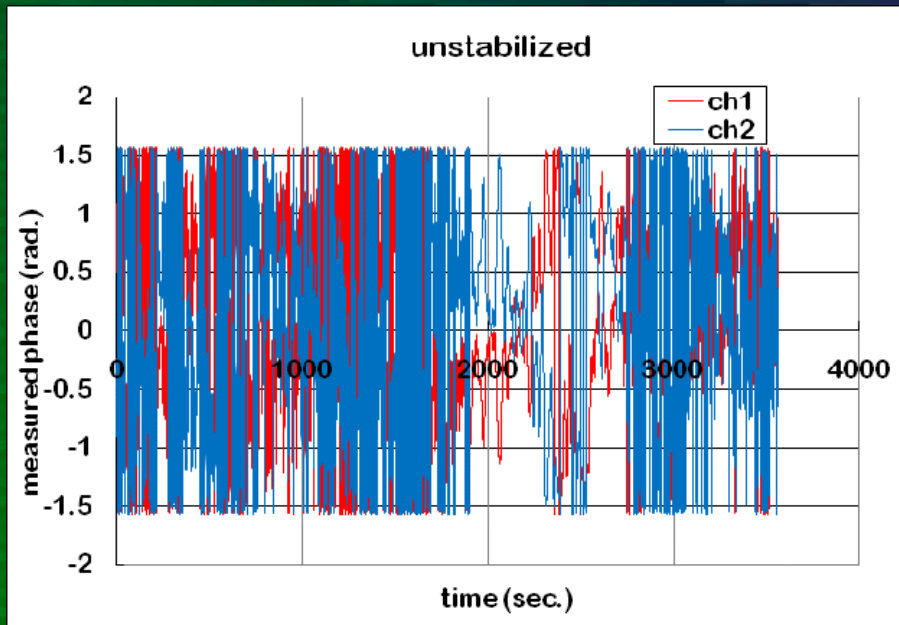


# Fringe Phase Scanning System



- Optical delay line used for phase stabilization and scan
- Resolution of piezo stage is 1nm, corresponds to 2nm phase resolution.
- We implemented a test stabilization system using the image sensor and this scanner.

# Phase Stabilization Test Result



- Stabilization effect is clearly observed.
- $\sigma = 0.076$  rad. (3.2nm) for ch1 (stabilized channel)
- $\sigma = 0.178$  rad. (7.5nm) for ch2 (not stabilized channel, except long-time drift)
- **Almost achieved 10nm stability** in spite of very bad condition (no cover, lenses with rods). We can improve.

# Issues of phase stabilization

- Resolution of image sensor is low (25  $\mu\text{m}$  pix.). We are improving it by new 5  $\mu\text{m}$  pix. sensor.
- Sensor characteristics of pulsed light are unknown (but the maker said it may be OK.) We need to test that by a pulsed laser.
- We need to know what causes the phase drift. (may be thermal, but not tested yet)
- Stabilization algorithm can be optimized.

# Other Topics

- Laser beam position at IP must be stabilized for good fringe contrast.  
FFTB version had 2 PSD sensors and mirror movers for stabilization system.  
We are implementing a new system (using existing PSD).
- Power of split laser beam should be equal.  
We plan to correct it by a Pockels cell.  
(Normal variable ND filter cannot be used for high power.)  
The Pockels cell can be also an alternative for phase scanning device (without polarizer).
- We need some tests by pulsed laser (low & high power).  
We found timing jitter of laser is 1ns ( $\sigma$ ) in specification.  
It must be also corrected. We will use TDC.

# Requests

Beam collimation

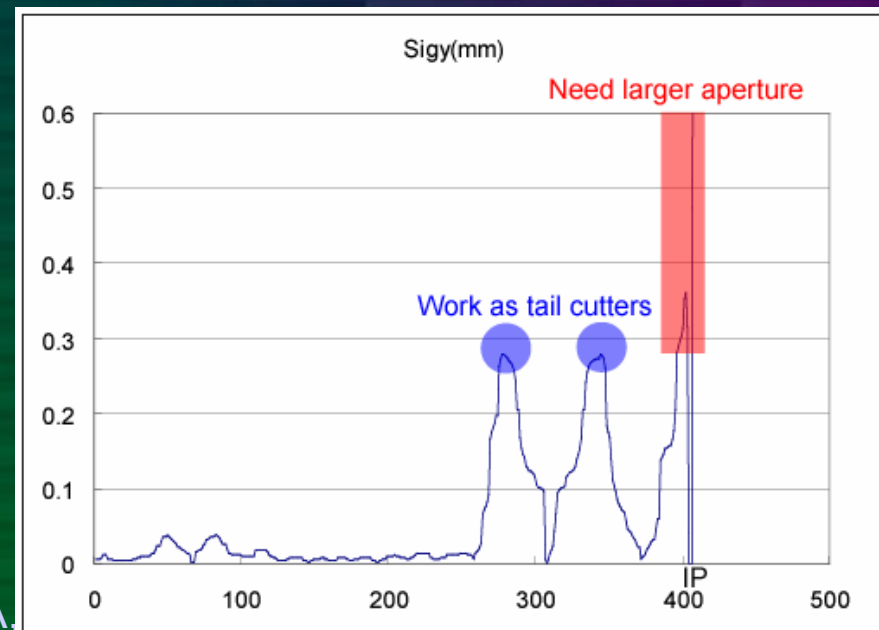
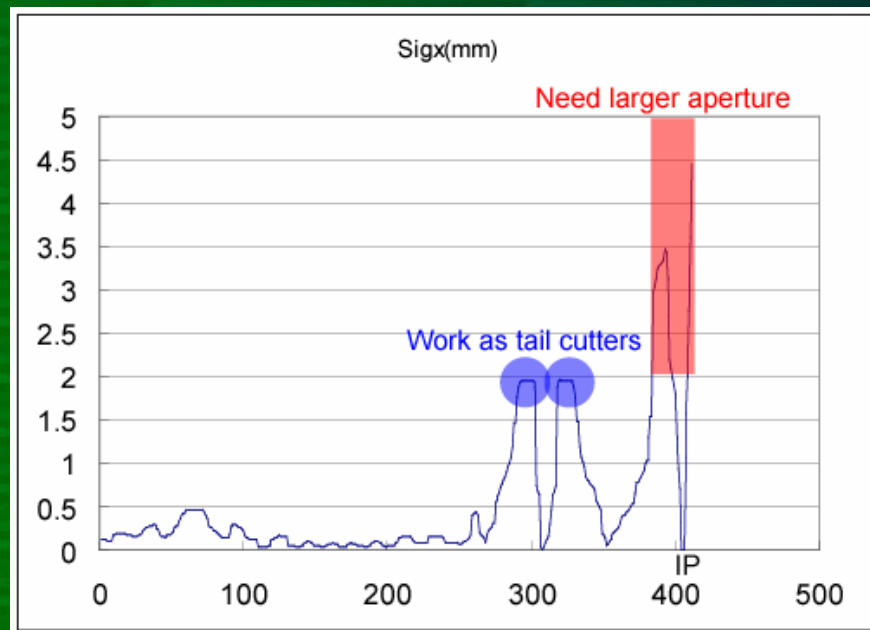
Hall layout

Laser

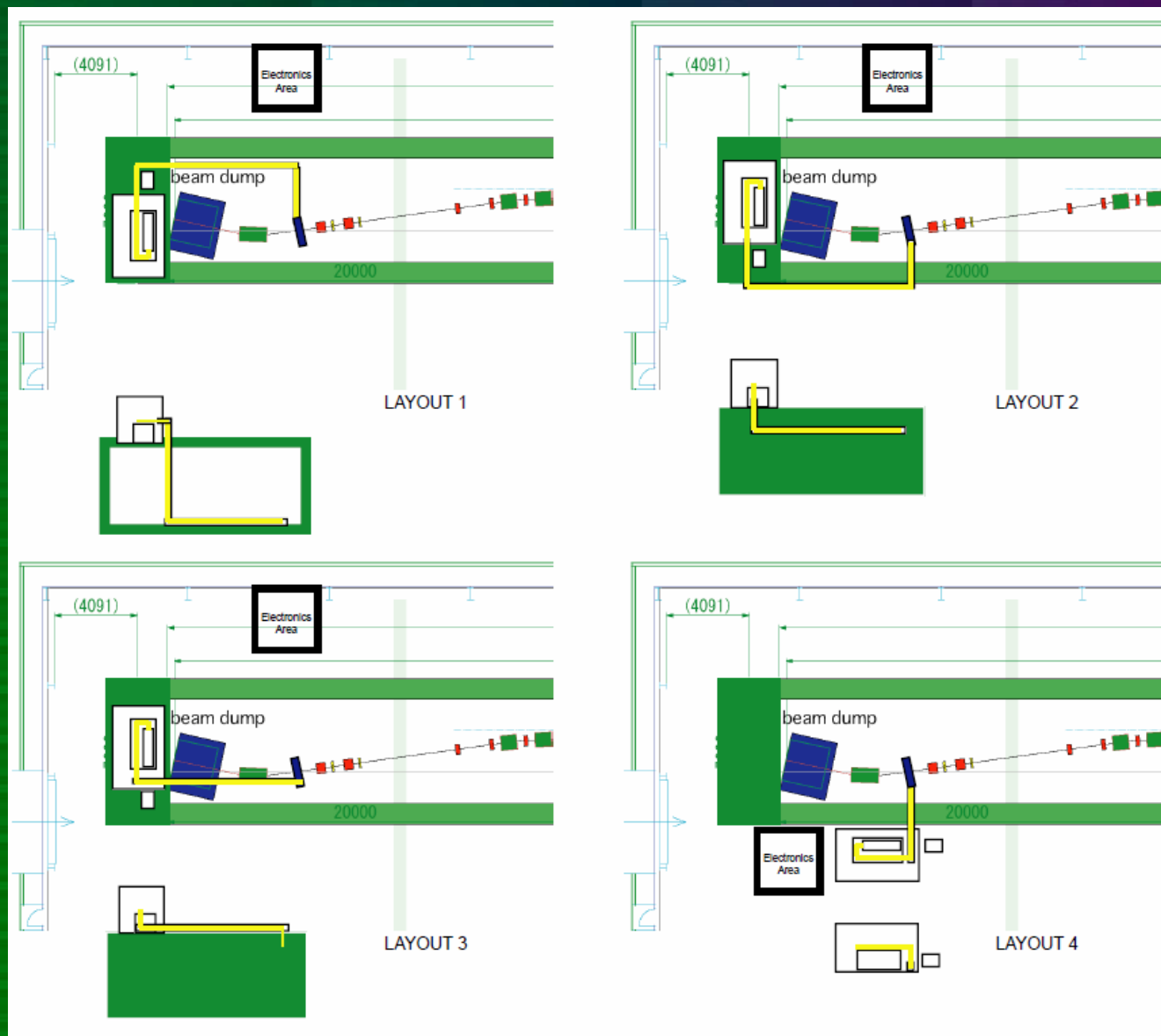


# Request for Beam Collimation

- Cut of beam tail is necessary for both X & Y.
- Maximum  $\sigma_x$  before final bend  $\sim 1.95$  mm
  - Aperture of OC1~SD0 must be larger (S-band)
  - Beam size between IP and dump must be also considered.
- Maximum  $\sigma_y$  before final bend  $\sim 0.27$  mm
  - Aperture of LXS.9~QD0 must be larger (S-band)
  - Beam size between IP and dump must be also considered.



# Hall layout



- About 3m x 6m space needed for the laser hut.
- On the top of the shield (end of beam line) is acceptable.
- Laser transport line will go through wall or ground.

# Laser

- The power of FFTB laser is not sufficient
  - 320mJ, 532nm, 10Hz, 8nm bunch length
  - Bunch length is too long, > 99% of the beam is “out of the date”. 100ps is enough.
  - Average number of Compton photons is ~1000. may be buried by background.
  - Number of Compton photons is proportional to laser power.
- Laser with more power / shorter bunch is highly desirable.

# Summary & Plan

- Laser “phase stabilization” is essential for 2nm beam size resolution.
- Required phase stability is 10nm, which is almost achieved by active stabilization with linear image sensor phase monitor.
- Now we use cw. low power laser. We will perform test with pulsed / high power laser.
- We plan to finish tuning optics before next autumn (detailed schedule will be showed in the schedule session).

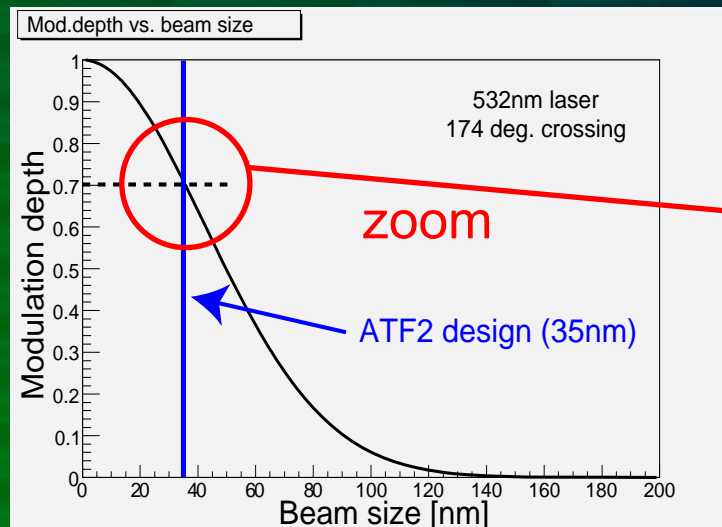
**Thank you!!**

# ATF2 Shintake-monitor group

- Students
  - Taikan SUEHARA (Univ. of Tokyo, D2)
    - Optics (main table, laser table)
    - Overall design,etc.
  - Hakutaro YODA (Univ. of Tokyo, M1)
    - Gamma detector
- Staffs
  - Tatsuya KUME (KEK)
    - Optics support
    - Table support frame
  - Yosuke Honda (KEK)
    - Support (optics etc.)
  - T.Tauchi (KEK), T.Sanuki (Univ. of Tokyo)
    - Advisor (ATF2, overall)

# Required Modulation Resolution

GOAL : to measure 35 nm beam size  
by  $< 2\text{nm}$  resolution



Beam size	modulation
33nm	73%
35nm	70%
37nm	67%

2nm beam size corresponds  
to 3% modulation (around 35nm).  
**We need 3% modulation resolution.**

Then, how much stability of laser fringe phase  
do we need to achieve 3% modulation resolution?  
→ **We performed a Monte Carlo simulation** to obtain that relation.

# Modulation Error Estimation

Assumed measuring condition for simulation is:

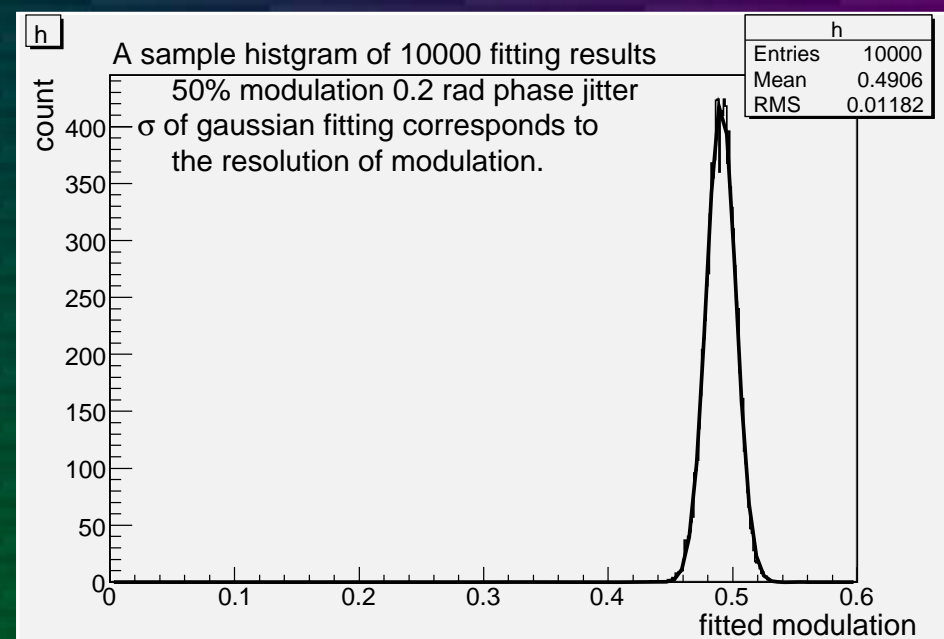
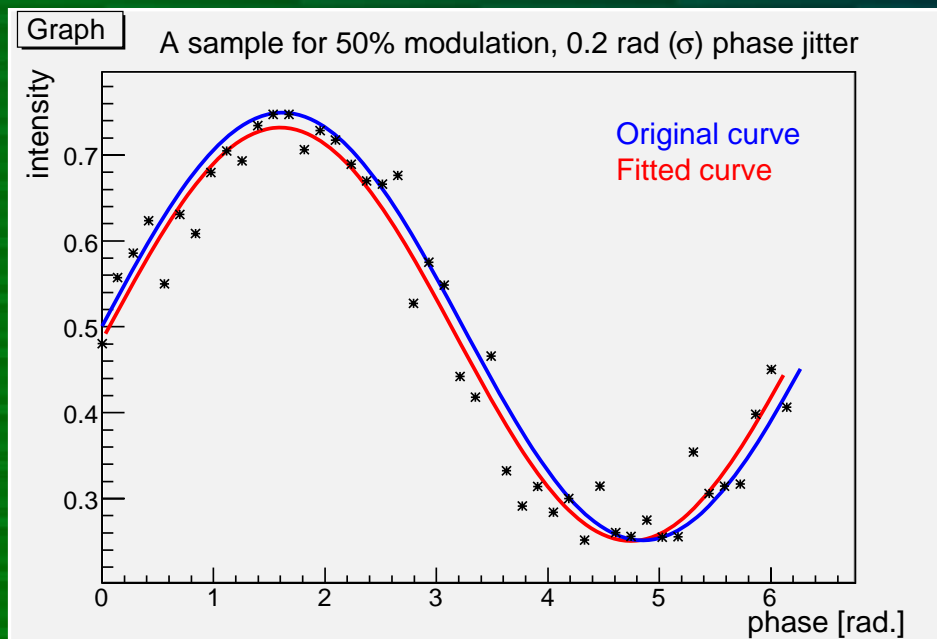
**45 points (phases) meas., 1 bunch for each point**

It's determined by desired measuring time (1 minute)

45 points  $\times$  1 bunch + same for background reduction = 90 bunches.

90 bunches / 1.5 Hz (ATF2 operation freq.)  $\sim$  60sec.

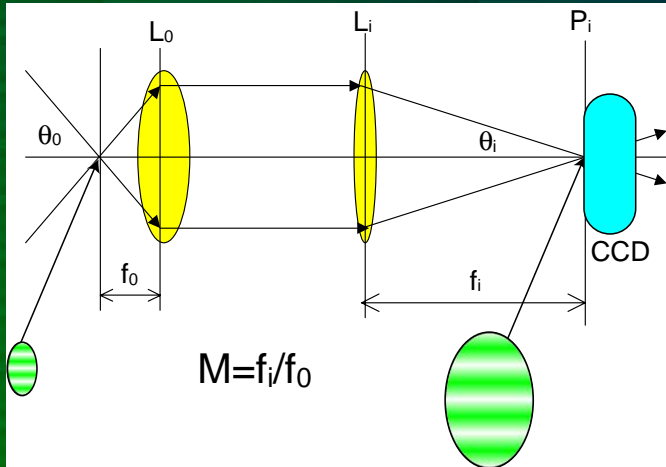
Simulation method is shown below (by example)



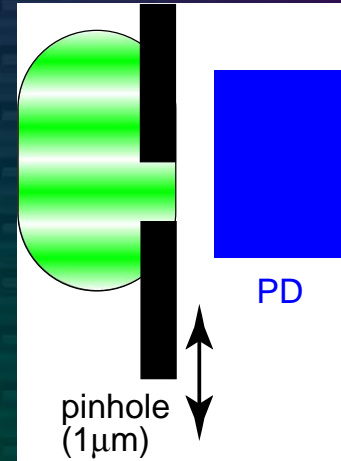
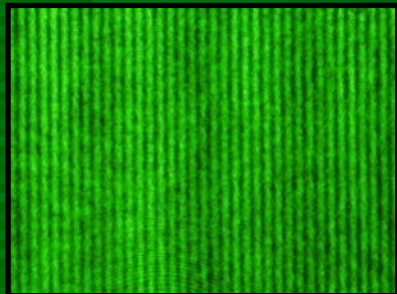
A sample of error simulation caused by phase jitter



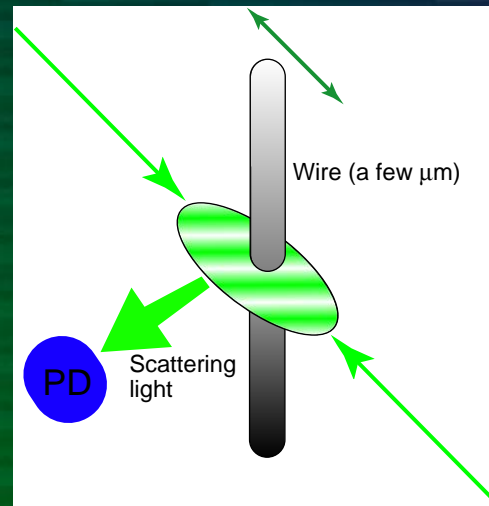
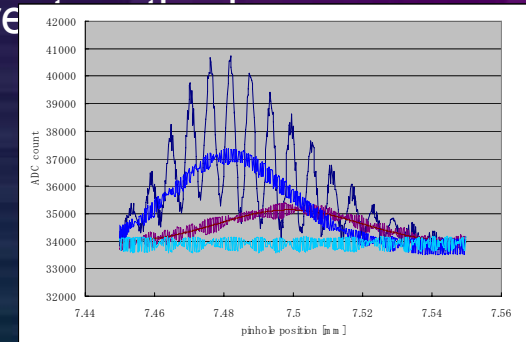
# Phase detection method



CCD with fringe magnify optics  
 (using microscope lens)  
 > 1 μm fringe (6°, 30° setup)  
 single shot (usable for online monitor)  
 indirect method (need to check  
 responsibility)

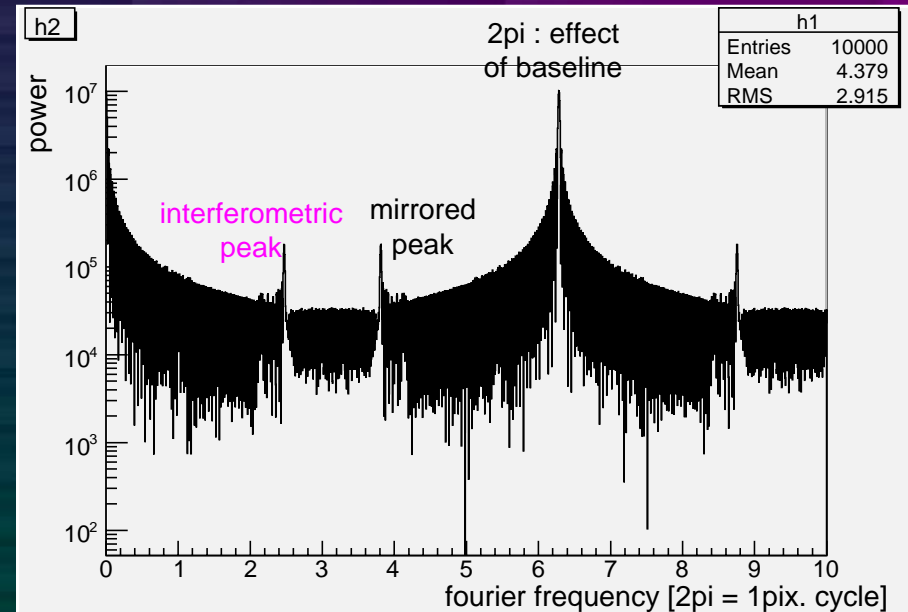
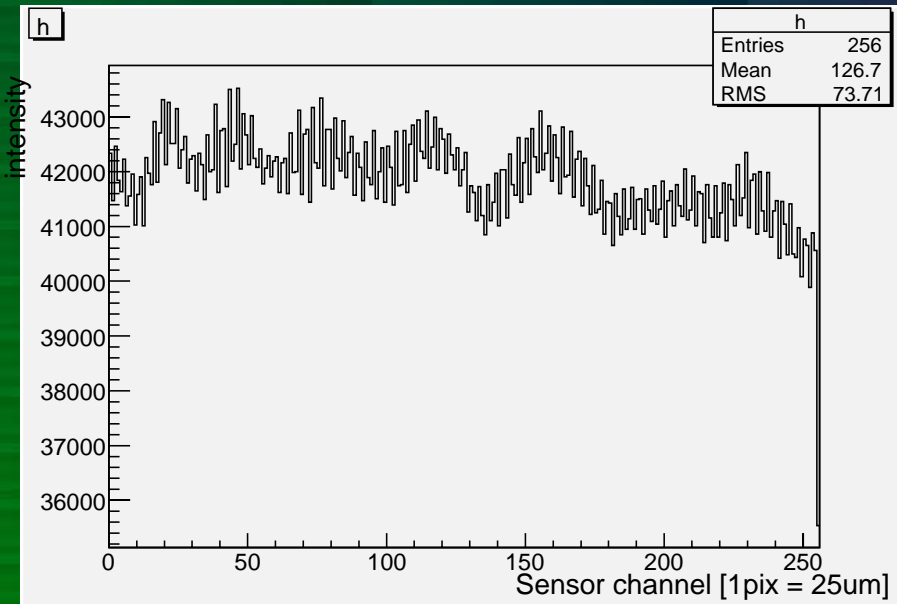


Pinhole scan  
 > 1 μm fringe (6°, 30° setup)  
 not single shot  
 simple theory  
 (good for cross check)  
 direct method



Wire scan  
 ~ 250nm fringe  
 (all setup)  
 not single shot  
 tuning is difficult  
 direct method

# Linear Image Sensor Data



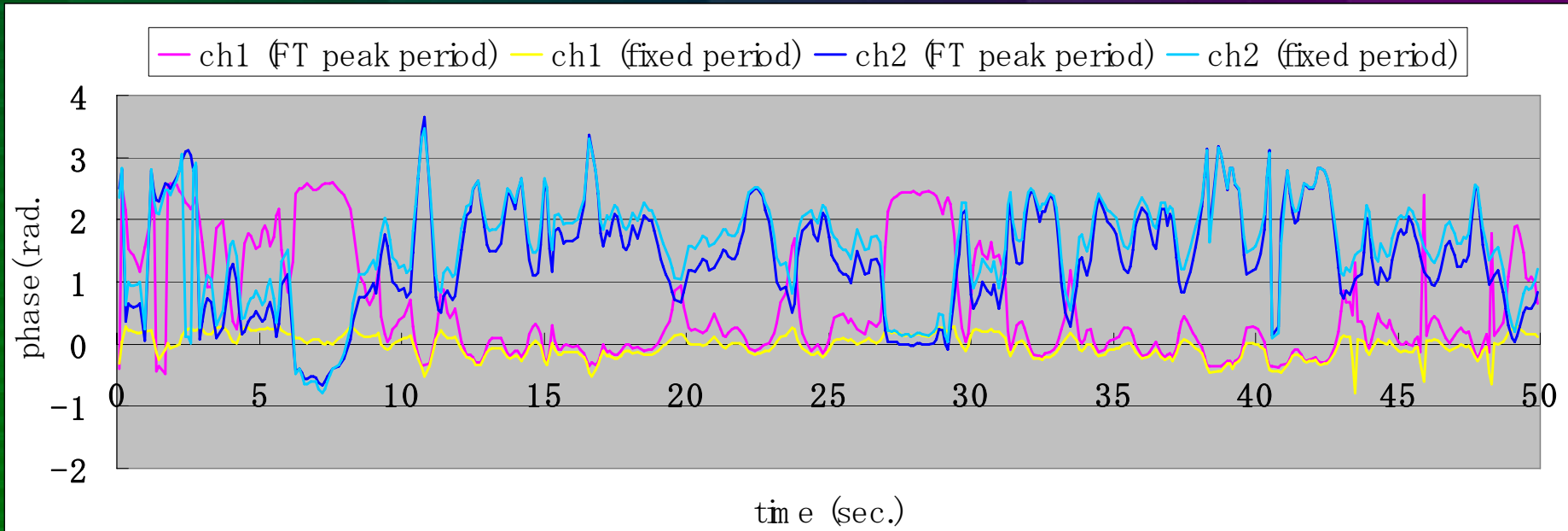
Raw spectrum. Wave of dense pitch

Fourier spectrum. Clear peak near 2.5.

- We use **Fourier transform** to obtain phase (at central channel) for high resolution and noise reduction.
- Clear peak can be seen near 2.5 on Fourier spectrum. It corresponds to the wave seen on raw spectrum.
- We use the **Fourier phase (i.e. argument of complex Fourier) of the peak** for the phase stabilization.

# Preliminary Result(1)

Simply measured phase for 50 sec. No stabilization.



FT peak period: the phase of the Fourier peak freq.

Fixed period: the phase of fixed freq. (near the peak).

- Ch1 and Ch2 are almost opposite because they face opposite directions (it's expected behavior).
- This shows **correlation of phases at two monitors.**

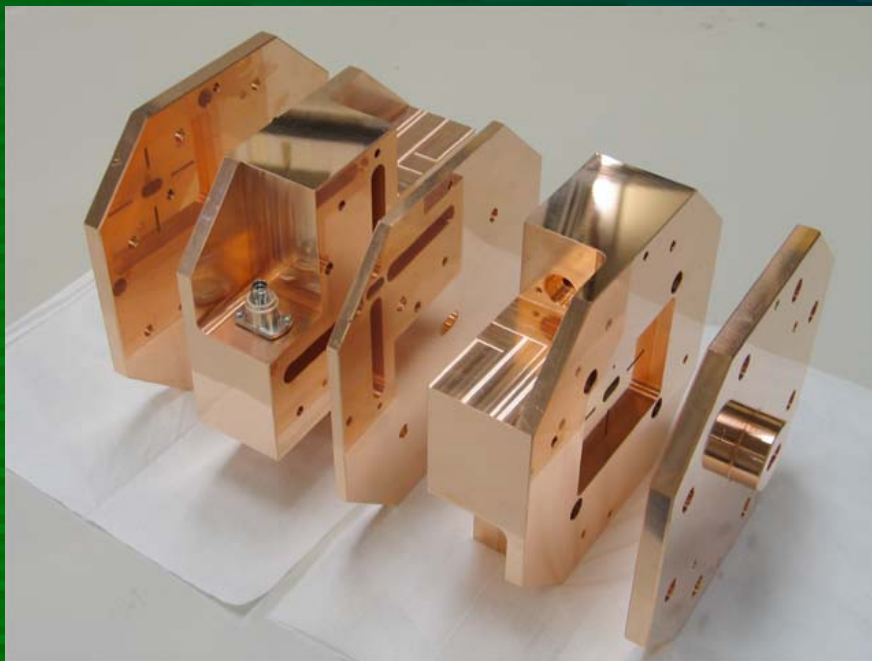
# Fringe phase stabilization strategy

# Stabilize to what?

- We have to know **the point of origin** of stabilization.
- We want to stabilize fringe to beam position
  - We cannot stabilize directly to “beam position”.
  - How to obtain beam position? (2 possibilities)
    - IP BPM. The other purpose of ATF2 is to achieve 2nm stabilization of beam position. IP BPM is used to achieve that.  
→ **We can use the BPM center as the point of origin.**
    - Position of the Final Doublet can be translated to beam position  
→ **Position of the Final Doublet  
can also be the point of origin.**
- We are creating a stabilization system for above 2 points of origin (may be selectable).

# First possibility : with IPBPM

- IPBPM will be able to measure 2 nm BP.  
Dr. Honda and Mr. Nakamura are developing the IPBPM.
- We plan to attach IPBPM within Shintake-monitor.

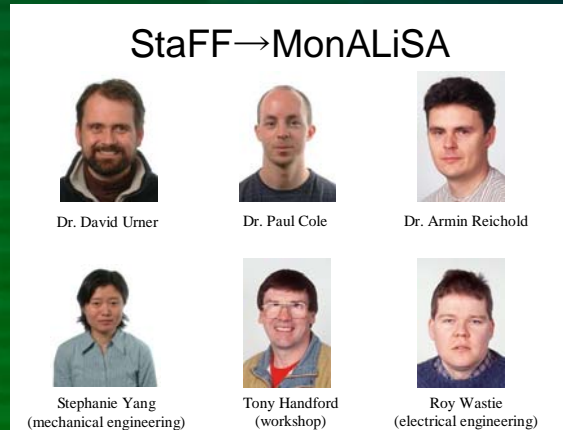


IP BPM prototype by Dr.Honda

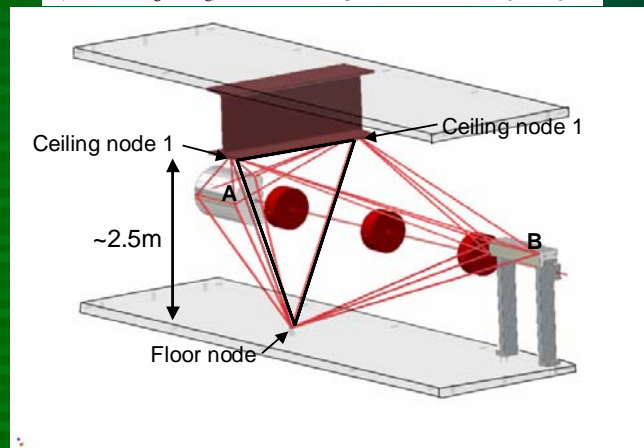
- If IPBPM has enough resolution, we can use that (BPM cavity) as the point of origin.



# Second possibility : with MonALiSA position monitor



- MonALiSA (former StaFF) uses a laser interferometer to monitor position between some objects.
- Position of Final Doublet is correlated to beam position (by the relation of lens and focus point).
- We can define the point of origin freely in Shintake table (MonALiSA can monitor the point).



MonALiSA people and their proposed monitor (Urner's talk on ATF2 project meeting, May 2006)

